

The system developed was tested under both field and bench conditions. The results obtained confirm our theoretical ideas used for the development of the structure of excitation system and for construction individual units and demonstrate improved flexibility of the system operation as compared to the known ones. Based on these data a Nd:YAG-laser compatible power supply BINOM

was constructed. It allows laser operation at elevated pulse repetition rate. BINOM is designed as a desk unit including power supply, charging unit, capacitive energy storage, high-voltage rectifier, generator of high-voltage pulses for EOS control, control system for variation and stabilization of pumping power and synchronizing pulse formation. The picture of the device BINOM is presented in Fig.2.

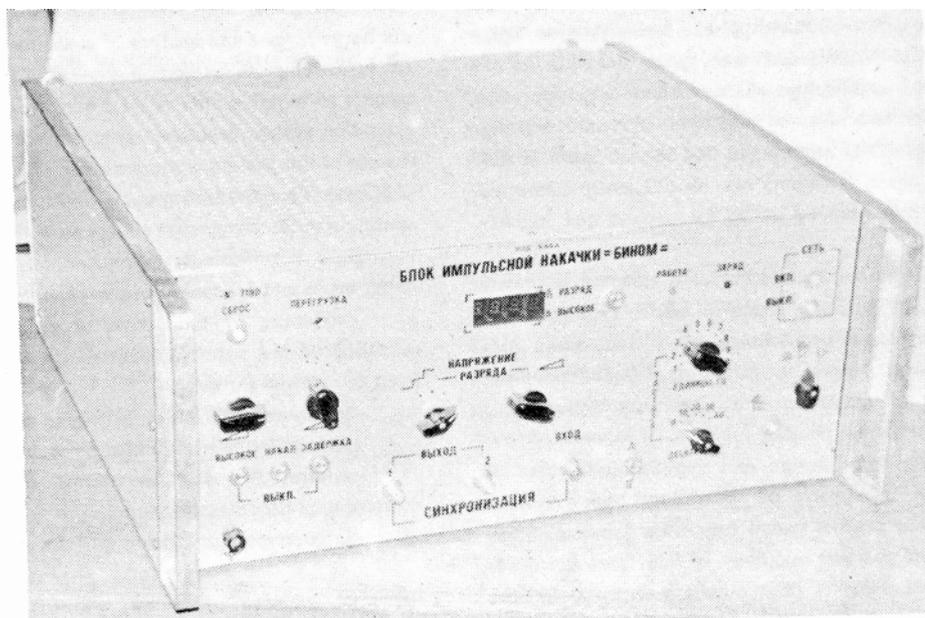


FIG. 2.

Basic specifications of the power supply

Limits of fine variation of the charging voltage, V	250–1000
Pulse energy, J	3–50
Energy instability	1%
Pulse repetition rate, Hz	0–150 (fine variation) including single-shot operations
Type of pumping flash lamp	IFP–800, ISP–2500 and similar ones
Maximum power consumed, kW	8
Mass, kg	60
Size, mm	480×350×285